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1

2 **Title**

3 Mechanism of Electrolytic Reduction of SiO₂ at Liquid Zn Cathode in Molten CaCl₂

4

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19

20 **Abstract**

21 The reaction mechanism of electrolytic reduction of SiO₂ at a liquid Zn cathode
22 in molten CaCl₂ was investigated with the aim of establishing a new production process
23 of solar-grade Si. Three types of Zn/SiO₂ contacting electrodes were prepared
24 depending on the objectives. Cyclic voltammetry suggested two reduction mechanisms
25 of SiO₂ at a Zn electrode. One is a direct electrolytic reduction that proceeds at
26 potentials more negative than 1.55 V vs. Ca²⁺/Ca. The other is an indirect reduction by
27 liquid Ca–Zn alloy at potentials more negative than 0.85 V. The both reduction
28 mechanisms were confirmed to proceed at 0.60 V by electrolysis and immersion
29 experiments. Impurity analysis by ICP-AES was conducted for the Si prepared by
30 potentiostatic electrolysis at 0.60 V, and confirmed that the concentrations of the metal
31 elements and P were lower than the target levels for primary Si before directional
32 solidification process.

33

34 **1. Introduction**

35 Photovoltaic (PV) power generation has attracted attention as a source of green
36 energy that can substitute the conventional fossil-based energy. The global production of

37 PV cells has experienced a rapid growth in the last decade. Accordingly, their
38 production volume increased in the 21st century by a factor of approximately 250 i.e.,
39 from 0.285 GW in 2000 to 75.5 GW in 2016. Among the many types of solar cells,
40 crystalline Si solar cells accounted for 94.3% of the worldwide production in 2016¹. The
41 global production of high-purity crystalline Si also increased to 412,600 tons in 2016
42 i.e., by a factor of approximately 18 over the level achieved in 2000². Therefore,
43 crystalline Si solar cells would most likely remain the main product of the PV industry
44 in the long term.

45 The high-purity Si used in crystalline Si solar cells is known as solar-grade Si
46 (SOG-Si), and requires a purity of 6–7N. Approximately 90% of SOG-Si is currently
47 produced by the Siemens process^{3–5}. To develop a next-generation production process
48 for SOG-Si, purification of metallurgical-grade Si^{6–11} and metallothermic reduction of
49 silicon halides by metal reductants^{12–15} were investigated. One of the metallothermic
50 reduction processes proposed is a reduction of SiCl₄ by Zn, and is known as the Du Pont
51 process, which was the commercial process for high-purity Si production before the
52 Siemens process was introduced¹². There are two major advantages of the Du Pont
53 process. One is no formation of Si–Zn intermetallic compounds due to the low chemical
54 affinity of Zn with Si¹⁶. The other is the easy removal of the unreacted Zn and ZnCl₂

55 generated from the Si product because of their high vapor pressures.

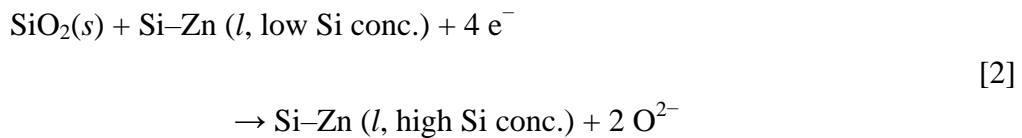
56 For the past two decades, we have been studying the direct electrolytic
57 reduction of solid SiO₂ to Si in molten CaCl₂ as a new production process of SOG-Si¹⁷⁻
58 ²⁰. Here, since purification of SiO₂ up to 6-7N is possible at low cost^{21,22}, such purified
59 SiO₂ is assumed to be used as the raw material²². In this process, electrochemical
60 reduction of insulating SiO₂ is realized by using a SiO₂ contacting electrode, which
61 provides the three-phase zone of conductor/SiO₂/CaCl₂¹⁷.



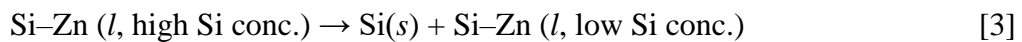
62 Several other research groups have also investigated the direct electrolytic reduction of
63 SiO₂²³⁻³⁴. One of the challenges faced in the industrial application of this process is the
64 efficient recovery and separation of the powdery Si product from unreacted SiO₂ and
65 molten CaCl₂³⁵.

66 Recently, we proposed an electrolytic reduction process of SiO₂ using a liquid
67 Zn cathode in molten CaCl₂. Since the electrolysis product is liquid Si-Zn alloy, its
68 separation from unreacted SiO₂ and molten salt is expected to be easier than that
69 entailed in the use of the conventional solid cathode^{36, 37}. The choice of Zn as an
70 alloying element stems from the very factors that render the Du Pont process
71 advantageous, i.e., the use of Zn ensures the formation of no intermetallic compounds

72 with Si, and facilitates easy removal of both Zn and ZnCl₂. Here, the most important
73 point is that the existence of molten salt over liquid Zn effectively suppresses the
74 evaporation of Zn even at high temperatures such as 1123 K. Figure 1 schematically
75 illustrates the proposed process^{36,37}. The overall process consists of three major steps:
76 electrolysis, precipitation, and refining. In the electrolysis step, solid SiO₂ is reduced to
77 form liquid Si–Zn alloy at a liquid Zn cathode.



78 In the precipitation step, solid Si is recovered by lowering the temperature of the liquid
79 Si–Zn alloy.



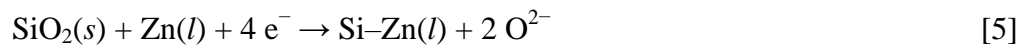
80 Since the solubility of Si in liquid Zn is 6 at.% at 1123 K and 1 at.% at 923 K³⁸, 5 at.%
81 of solid Si with reference to Zn is theoretically recovered when the temperature is
82 lowered from 1123 K to 923 K. After the precipitation step, the Si–Zn alloy with a low
83 concentration of Si is reused as the cathode in the electrolysis step. The Si recovered is
84 then subjected to the refining step: that entails vacuum refining to remove residual Zn
85 and directional solidification to manufacture SOG-Si ingots.

86 In our previous study, the suppression of evaporation of Zn metal by covering it

87 with molten CaCl_2 was confirmed at $1123 \text{ K}^{36, 37}$. Moreover, the alloying rate between
88 solid Si and liquid Zn was measured, and the formation of liquid Si–Zn alloy at a liquid
89 Zn cathode was demonstrated^{36, 37}. After potentiostatic electrolysis at 0.9 V, Si particles
90 of sizes in the range 2–30 μm were precipitated in the solidified Zn matrix. The
91 formation of liquid Ca–Zn alloy (reaction [4]) was also suggested by cyclic
92 voltammetry.



93 Based on these results, the electrolytic reduction of SiO_2 at a liquid Zn cathode was
94 considered to be a mixed mechanism of (A) direct electrolytic reduction of SiO_2
95 (reaction [5]), and (B) indirect reduction of SiO_2 by liquid Ca–Zn alloy (reaction [6]).



96 However, the evidence of (B) i.e., indirect reduction was not seen, and the contributions
97 of (A) and (B) were not investigated.

98 In the present study, a series of electrolysis and immersion experiments were
99 conducted to confirm the indirect reduction of SiO_2 . Based on the results, the mixed
100 reduction mechanism was discussed in terms of reduction rate. Finally, impurity
101 analysis was performed for the Si particles produced at the Zn cathode.

102

103 **2. Experimental**

104 All experiments were performed in a dry Ar atmosphere at 1123 K. An Ag^+/Ag
105 electrode was used as the reference electrode in the experiments. The experimental
106 conditions for (a) cyclic voltammetry, (b) electrolytic reduction of SiO_2 plates, and (c)
107 electrolytic reduction of SiO_2 particles are described below.

108

109 (a) Cyclic Voltammetry

110 Figure 2 shows a schematic illustration of the electrolysis cell for the
111 observation of the reduction behavior of SiO_2 at a liquid Zn cathode. Figure 3(a)
112 schematically illustrates the structure of the liquid Zn working electrode for cyclic
113 voltammetry. Approximately 70 g of Zn (Wako Pure Chemical Corp., reagent grade,
114 granule) was charged into a small Al_2O_3 crucible (AS ONE, o.d. 45 mm \times height 36 mm,
115 $>99\%$). The small Al_2O_3 crucible was placed at the bottom of another Al_2O_3 crucible
116 (AS ONE, o.d. 90 mm \times i.d. 80 mm \times height 140 mm, $>99\%$), and approximately 500 g
117 of CaCl_2 (Kojundo Chemical Laboratory Co., Ltd., $>99\%$) was charged. A W wire (The
118 Nilaco Corporation, diameter 2.0 mm, 99.95%) threaded into an Al_2O_3 tube (Nikkato
119 Corp., SSA-S grade, o.d. 6.0 mm \times i.d. 4.0 mm) or a SiO_2 tube (Soei Riken Corp., o.d.

120 6.0 mm × i.d. 2.0 mm) was used as the current lead and immersed in the liquid Zn in the
121 small Al₂O₃ crucible. The direct electrolytic reduction of SiO₂ occurs at the three-phase
122 interface of (Al₂O₃ or SiO₂)/CaCl₂ (l)/Zn (l), as shown in Fig. 3(a). For comparison, a
123 square-shaped plate of single-crystal Si (ca. 30 mm × 5 mm × 0.5 mm, p-type, (100),
124 $1.5\text{--}3.0 \times 10^{-3} \Omega \text{ cm}$ at 298 K) was also used as the working electrode. The counter
125 electrode was a square graphite bar (Toyo Tanso Co., Ltd., 5 mm × 5 mm × height 50
126 mm).

127

128 (b) Electrolytic reduction of SiO₂ plates

129 Figure 3(b) shows a schematic illustration of the liquid Zn cathode for the
130 investigation of the effect of indirect reduction of SiO₂ by liquid Ca–Zn alloy.
131 Approximately 125 g of Zn was charged into a small ZrO₂ crucible (AS ONE, ZrO₂
132 91.5%, Y₂O₃ 8%, o.d. 60 mm × i.d. 52 mm × height 35 mm). The ZrO₂ crucible was
133 placed in a graphite crucible (Toyo Tanso Co., Ltd., IG-110 grade, o.d. 100 mm × i.d. 90
134 mm × height 120 mm) to which a graphite rod (Toyo Tanso Co., Ltd., IG-110 grade,
135 diameter 9 mm) was fixed using a stainless steel screw. Approximately 500 g of CaCl₂
136 was charged into the graphite crucible. A SiO₂ plate (Soei Riken Corp., 25 mm × 10 mm
137 × thickness 1 mm), fixed to an insulating tube of Al₂O₃ (Nikkato Corp., SSA-S grade,

138 o.d. 2.5 mm \times i.d. 1.5 mm) by winding a Mo wire (The Nilaco Corporation, diameter
139 0.20 mm, 99.95%), was immersed into the liquid Zn in the small ZrO₂ crucible. The
140 counter electrode was the graphite crucible, and the graphite rod was used as the current
141 lead. The test piece prepared by electrolysis or immersion of SiO₂ plate was washed
142 with distilled water to remove the salt, and then immersed in HCl aq. (3 wt.%, prepared
143 from Fujifilm Wako Pure Chemical Corporation, reagent grade, 36 wt.%) overnight to
144 dissolve the Zn metal on the surface of the plate. An optical microscope (Thanko Inc.,
145 DILITE30) was used for surface observation, and the masses of the SiO₂ plates were
146 measured before and after the experiment.

147

148 (c) Electrolytic reduction of SiO₂ particles

149 Figure 4 schematically illustrates a cell for the electrolytic reduction of SiO₂
150 particles. A total of 335 g of Zn and 349 g of CaCl₂ were charged into an Al₂O₃ crucible.
151 After the temperature was raised to 1123 K, a total of 16.2 g of SiO₂ particles (Kojundo
152 Chemical Laboratory Co., Ltd., 0.25–1.00 mm, 99.995%) was charged into molten salt
153 uniformly using a quartz funnel. The SiO₂ particles floated on the surface of liquid Zn in
154 molten CaCl₂ because the densities of liquid CaCl₂, solid SiO₂, and liquid Zn are 2.05 g
155 cm⁻³, 2.2 g cm⁻³, and 5.9 g cm⁻³, respectively, at 1123 K. A W wire (The Nilaco

156 Corporation, diameter 1.0 mm, 99.95%) threaded into an alumina tube was used as the
157 current lead for liquid Zn. The counter electrode was a graphite rod (Toyo Tanso Co.,
158 Ltd., IG-110 grade, diameter 20 mm × height 40 mm) fixed to a thinner graphite rod
159 (Toyo Tanso Co., Ltd., IG-110 grade, diameter 9 mm × height 500 mm). The sample
160 obtained after electrolysis was cooled from 1123 K to 773 K for 35 h, then maintained
161 at 773 K for 10 h, and further cooled to 298 K for 5 h. The ingot of Zn metal was
162 recovered after the removal of CaCl₂ by flowing water. The Zn metal ingot was
163 dissolved in HCl aq. (20 wt.%). The particles recovered after the dissolution of HCl
164 were further washed; they were alternately immersed in HCl aq. (10 wt.%) twice and in
165 HF aq. (5 wt.%, prepared from Tama Chemicals Co., Ltd., AA-100 grade, 38 wt.%)
166 once overnight. The analysis was conducted using X-ray diffraction (XRD, Rigaku,
167 Ultima 4, Cu-K α , $\lambda = 1.5418 \text{ \AA}$, 40 kV, 40 mA) and inductively coupled plasma atomic
168 emission spectroscopy (ICP-AES; AMETEK, Inc., SPECTROBLUE).

169

170 **3. Result and Discussion**

171 (a) Cyclic Voltammetry

172 Figure 5 shows the cyclic voltammograms at the liquid Zn (black color) and Si
173 plate (red color) electrodes. As for the Si electrode, the cathodic and anodic current

174 peaks at around 1.3–1.4 V vs. Ca^{2+}/Ca correspond to the reduction of surface SiO_2 film
175 to metallic Si and the oxidation of Si into SiO_2 layer, respectively^{35, 39}. The smaller
176 anodic current compared with the cathodic current is due to the passivation effect of the
177 formed SiO_2 layer. The redox at 0.5 V is attributed to CaSi_2/Si ^{35, 39}. The solid and
178 broken black lines show the voltammograms at Zn electrodes using Al_2O_3 and SiO_2
179 tubes, respectively. A sharp increase in cathodic current at 0.85 V is seen at both the Zn
180 electrodes. Since the electrochemical reduction of Al_2O_3 does not occur in the potential
181 range measured⁴⁰, the cathodic current is attributed to the formation of liquid Ca–Zn
182 alloy, which was already confirmed by potentiostatic electrolysis at potentials more
183 negative than 0.85 V³⁷. In the case of the Zn electrode with SiO_2 , the rest potential is
184 1.55 V, which is more positive than that of the Si plate electrode (1.47 V), and the
185 cathodic current is observed from the rest potential in the negative scan even at
186 potentials more positive than 1.3 V. These results suggest the formation of liquid Si–Zn
187 alloy with Si activity lower than unity with respect to pure solid Si. The cathodic current
188 at the Zn electrode with SiO_2 was 80 mA larger than that with Al_2O_3 , which also
189 suggests electrolytic reduction of SiO_2 (reaction [5]).

190

191 (b) Electrolytic reduction of SiO_2 plates

192 On the basis of the voltammetry results, potentiostatic electrolysis was first
193 conducted at 0.60 V and then at 0.90 V. Specifically, the experiments were conducted in
194 the following order: [A1] electrolysis at 0.90 V for 30 min, [B1] immersion for 30 min,
195 [A2] electrolysis at 0.60 V for 30 min, and [B2] immersion for 30 min. Here, a new
196 SiO₂ plate was used in each step. As a result, four samples, A1, B1, A2 and B2, were
197 prepared. Since electrolysis was not conducted for the samples B1 and B2, the reduction
198 of SiO₂ could be advanced only due to indirect reduction by liquid Ca–Zn alloy
199 (reaction [6]). On the other hand, the reduction of the samples A1 and A2 could proceed
200 by a mixed reduction mechanism comprising direct electrolytic reaction (reaction [5])
201 and indirect reduction by liquid Ca–Zn alloy.

202 The optical images of the samples A1, B1, A2, and B2 are shown in Figure 6.
203 For the sample A1, which was electrolyzed at 0.90 V, a change in color from transparent
204 i.e., no color to dark brown is observed in a portion lower than the Zn/CaCl₂ interface (8
205 mm from the bottom of the SiO₂ plate). Also, a decrease in plate thickness is clearly
206 observed. In the case of the sample A2, which was electrolyzed at 0.60 V, the entire area
207 below the Zn/CaCl₂ interface changed to dark brown in color. In this case, the plate
208 became thinner, showing that a larger amount of the Si–Zn liquid alloy was produced.
209 The thickness was more decreased near the three-phase interface of Zn/SiO₂/CaCl₂ in

210 comparison with the two-phase interface of Zn/SiO₂ in liquid Zn. This is explained by
211 higher solubility and faster diffusion of O²⁻ ions in molten CaCl₂ compared with those
212 in liquid Zn. As for the immersion sample B1, no dark brown part is observed,
213 indicating no progress of indirect reduction. Concerning the sample B2, which was
214 immersed after electrolysis at 0.60 V, the color of the immersed portion changed to dark
215 brown. This is explained by the indirect reduction. The weight losses of the samples
216 were 0.03 g (A1), 0.07 g (A2), 0.00 g (B1), and 0.03 g (B2).

217 By comparing the samples A1 and B1, it can be inferred that only the direct
218 reduction of SiO₂ (reaction [5]) occurs at 0.90 V. On the other hand, the results for
219 sample A2 and B2 conclude that comparable amount of reduction proceeded in the
220 indirect reaction, i.e., reduction by liquid Ca–Zn alloy (reaction [6]), in the electrolysis
221 at 0.60 V to the direct reduction.

222

223 (c) Electrolytic reduction of SiO₂ particles

224 To prepare a sample for impurity analysis, potentiostatic electrolysis of SiO₂
225 particles was conducted at 0.60 V for 50 h. Figure 7(a) shows a photograph of the
226 granules recovered after the dissolution of Zn by HCl solution and the treatment of acid
227 washing. The XRD analysis confirms that the granules are crystalline Si (Figure 7(b)).

228 The current efficiency (η) is calculated by the following equations:

$$\eta = \frac{W_{\text{act.}}}{W_{\text{theo.}}} \times 100 \quad [7]$$

$$W_{\text{theo.}} = \frac{Q}{4F} \times M_{\text{Si}} \quad [8]$$

229 where Q is the quantity of electric charge during electrolysis, F is Faraday's constant
230 (96485 C mol⁻¹), M_{Si} is the molar weight of Si (28.1 g mol⁻¹), $W_{\text{act.}}$ is the actual weight
231 of the Si recovered, and $W_{\text{theo.}}$ is the theoretical weight of Si by Faraday's law in
232 reaction [5]. From the values of $W_{\text{act.}} = 3.02$ g and $Q = 1.48 \times 10^5$ C, η is calculated to
233 be 28%. One of the reasons for the low current efficiency is the loss during acid
234 washing. Another is the formation of liquid Ca–Zn alloy as a side reaction; a part of it
235 contributes to the indirect reduction of SiO₂ and the other remains as Ca–Zn alloy.

236 Table 1 lists the impurity contents of the Si granules after the treatment of acid
237 washing. It also lists the acceptable levels for SOG-Si⁴¹, segregation coefficients⁷, and
238 target levels for primary Si for directional solidification. For comparison, the impurity
239 contents of the Si sample obtained by solid electrolytic reduction at 0.60 V for 5 h in
240 molten CaCl₂ are also shown⁴². The impurity levels of the metallic elements (Al, Ca, Fe,
241 and Ti) in the Si granules meet the target levels for the primary Si that is to be further
242 purified by unidirectional solidification according to the process proposed in Figure 1.
243 The content of P is also lower than the target level for the primary Si, and this is

244 noteworthy because the removal of P from elemental Si is known to be difficult. The
245 content of B is higher than the target level, and this needs to be improved in the future.
246 Overall, a comparison between the impurity concentrations in the Si products obtained
247 by electrolysis at a liquid Zn cathode and at a solid electrode indicates that higher purity
248 is achieved by the use of the liquid Zn electrode. The main reason for the higher purity
249 is the solidification refining during the precipitation of Si from the Si–Zn alloy wherein
250 most impurities remain in the liquid Zn phase. It should be mentioned that the Ca
251 concentration is lower than the target level for the primary Si in spite of the use of
252 indirect reduction by liquid Ca–Zn at 0.60 V. Calcium is also expected to be removed to
253 the Zn phase during precipitation. Although a relatively large amount of Zn (6055
254 ppmw) remained in the Si granules, this can be easily removed in the gas phase during
255 the refining process owing to its high vapor pressure.

256

257 **4. Conclusion**

258 The reaction mechanism of electrolytic reduction of SiO₂ at a liquid Zn cathode
259 was investigated in molten CaCl₂ at 1123 K. Cyclic voltammetry suggested that
260 electrolytic reduction of SiO₂ started from the rest potential (1.55 V), and liquid Ca–Zn
261 alloy was formed at potentials more negative than 0.85 V. The progress of the indirect

262 reduction of SiO₂ by liquid Ca–Zn alloy was confirmed by electrolysis and immersion
263 experiments. The reduction at 0.60 V proceeded by a mixed reduction mechanism of
264 direct electrolytic reaction and indirect reduction by Ca–Zn alloy. Impurity analysis
265 confirmed that the concentrations of the metal elements and P were lower than the target
266 levels for primary Si. The indirect reduction of SiO₂ by liquid Ca–Zn does not increase
267 the Ca content of the Si product because it is removed to the Zn phase during
268 precipitation.

269

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277

278 **References**

- 279 1. *Photovoltaic Market 2017*, RTS Corp. (2017). [in Japanese]
- 280 2. *Industrial Rare Metal 2017*, Arumu Publ. Co. (2017).

- 281 3. H. Schweickert, K. Reusche and H. Gustsche, U.S. Patent 3011877, (1961).
282 4. H. Gustsche, U.S. Patent 3011877, (1962).
283 5. C. Bye and B. Ceccaroli, *Sol. Energ. Mater. Sol. C.*, **130**, 634 (2014).
284 6. G. Burns, J. Rabe and S. Yilmaz, PCT International Patent WO2005/061383,
285 (2005).
286 7. F. A. Trumbore, *Bell Syst. Tech. J.*, **39**, 205 (1959).
287 8. X. Ma, T. Yoshikawa and K. Morita, *Sep. Purif. Technol.*, **125**, 264 (2014).
288 9. Y. Wang, X. Ma and K. Morita, *Metall. Mater. Trans. B*, **45**, 334 (2014).
289 10. K. Tang, S. Andersson, E. Nordstrand and M. Tangstad, *JOM*, **64**, 952 (2012).
290 11. K. Hanazawa, N. Yuge and Y. Kato, *Mater. Trans.*, **45**, 844 (2004).
291 12. D. W. Lyon, C. M. Olson and E. D. Lewis, *J. Electrochem. Soc.*, **96**, 359 (1949).
292 13. S. Yoshizawa, T. Hatano and S. Sakaguchi, *Kogyo Kagaku Zasshi*, **64**, 1347
293 (1961). [in Japanese]
294 14. J. M. Blocher, Jr., M. F. Browning and D. A. Seifert, DOE/JPL Report
295 954339-81/21 (1981).
296 15. A. Sanjurjo, PCT International Patent WO1983/002443, (1983).
297 16. T. B. Massalski, H. Okamoto, P. R. Subramanian and L. Kacprzak, *Binary Alloy*
298 *Phase Diagrams, 2nd ed.*, ASM International, Metals Park, Ohio, USA (1990).
299 17. T. Nohira, K. Yasuda and Y. Ito, *Nat. Mater.*, **2**, 397 (2003).
300 18. K. Yasuda, T. Nohira, K. Amezawa, Y. H. Ogata and Y. Ito, *J. Electrochem. Soc.*,
301 **152**, D69 (2005).
302 19. K. Yasuda, T. Nohira, R. Hagiwara and Y. H. Ogata, *Electrochim. Acta*, **53**, 106
303 (2007).
304 20. T. Nohira, *Yoyuen Oyobi Koon Kagaku*, **54**, 95 (2011). [in Japanese]
305 21. M. Bessho, Y. Fukunaka, H. Kusuda and T. Nishiyama, *Energy Fuels*, **23**, 4160
306 (2009).
307 22. T. Homma, N. Matsuo, X. Ynag, K. Yasuda, Y. Fukunaka and T. Nohira,
308 *Electrochim. Acta*, **179**, 512 (2015).
309 23. X. Jin, P. Gao, D. Wang, X. Hu and G. Z. Chen, *Angew. Chem. Int. Ed.*, **43**, 733
310 (2004).
311 24. P. C. Pistorius and D. J. Fray, *J. SAIMM*, **106**, 31 (2006).
312 25. S. Lee, J. Hur and C. Seo, *J. Ind. Eng. Chem.*, **14**, 651 (2008).
313 26. J. Yang, S. Lu, S. Kan, X. Zhang and J. Du, *Chem. Commun.*, 3273 (2009).
314 27. E. Juzeliunas, A. Cox and D. J. Fray, *Electrochem. Commun.*, **12**, 1270 (2010).
315 28. W. Xiao, X. Jin, Y. Deng, D. Wang and G. Z. Chen, *J. Electroanal. Chem.*, **639**,
316 130 (2010).

- 317 29. E. Ergül, İ. Karakaya and M. Erdoğan, *J. Alloy. Compd.*, **509**, 899 (2011).
318 30. S. Cho, F. F. Fan and A. J. Bard, *Electrochim. Acta*, **65**, 57 (2012).
319 31. H. Nishihara, T. Suzuki, H. Itoi, B. An, S. Iwamura, R. Berenguer and T. Kyotani,
320 *Nanoscale*, **6**, 10574 (2014).
321 32. S. Fang, H. Wang, J. Yang, S. Lu, B. Yu, J. Wang and C. Zhao, *Mater. Lett.*, **160**, 1
322 (2015).
323 33. S. Fang, H. Wang, J. Yang, S. Lu, B. Yu, J. Wang and C. Zhao, *Rare Metal*, **89**, 1
324 (2016).
325 34. S. Fang, H. Wang, J. Yang, S. Lu, B. Yu, J. Wang and C. Zhao, *J. Phys. Chem.*
326 *Solids*, **89**, 1 (2016).
327 35. T. Toba, K. Yasuda, T. Nohira, X. Yang, R. Hagiwara, K. Ichitsubo, K. Masuda
328 and T. Homma, *Electrochemistry*, **81**, 559 (2013).
329 36. T. Nohira, A. Ido, T. Shima, X. Yang, K. Yasuda, R. Hagiwara and T. Homma,
330 *ECS Trans.*, **75**, 17 (2016).
331 37. K. Yasuda, T. Shima, R. Hagiwara, T. Homma and T. Nohira, *J. Electrochem.*
332 *Soc.*, **164**, H5049 (2017).
333 38. R. W. Olensinski and G. J. Abbaschian, *Bull. Alloy Phase Diagr.*, **5**, 271 (1984).
334 39. K. Yasuda, T. Nohira and Y. Ito, *J. Phys. Chem. Solids*, **66**, 443 (2005).
335 40. H. Kadowaki, Y. Katasho, K. Yasuda and T. Nohira, *J. Electrochem. Soc.*, **165**,
336 D83 (2018).
337 41. N. Yuge, M. Abe, K. Hanazawa, H. Baba, N. Nakamura, Y. Kato, Y. Sakaguchi, S.
338 Hiwasa and F. Aratani, *Prog. Photovolt. Res. Appl.*, **9**, 203 (2001).
339 42. X. Yang, K. Yasuda, T. Nohira, R. Hagiwara and T. Homma, *Metall. Mater. Trans.*
340 *E*, **3**, 145 (2016).

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343 **Table and Figure captions**

344 Table 1 Impurity contents of Si granules obtained after acid leaching, and target levels
345 for primary Si of SOG-Si. The electrolytic reduction of SiO₂ particles was
346 conducted at 0.6 V for 50 h at a liquid Zn cathode in molten CaCl₂ at 1123 K.

347 Figure 1 Schematic drawing of SOG-Si production process using electrochemical
348 reduction of SiO₂ powder at a liquid Si–Zn alloy cathode in molten CaCl₂.^{36,37}

349 Figure 2 Schematic illustration of the electrolysis cell for observation of SiO₂
350 reduction behavior at liquid Zn cathode. (a) Ag⁺/Ag reference electrode, (b)
351 Ca²⁺/Ca dynamic reference electrode on a Mo wire, (c) liquid Zn electrode
352 with Al₂O₃/SiO₂ tube, (d) graphite counter electrode, (e) Al₂O₃ crucible, (f)
353 molten CaCl₂, (g) small Al₂O₃ crucible, and (h) liquid Zn.

354 Figure 3 Schematic illustrations of the liquid Zn electrode for (a) cyclic voltammetry
355 and (b) electrolytic reduction of SiO₂ plate.

356 Figure 4 Schematic illustration of the electrolysis cell for the electrolytic reduction of
357 SiO₂ particles. (a) Ag⁺/Ag reference electrode, (b) Ca²⁺/Ca dynamic reference
358 electrode on a Mo wire, (c) W lead wire, (d) graphite counter electrode, (e)
359 Al₂O₃ crucible, (f) molten CaCl₂, (g) SiO₂ particle, and (h) liquid Zn.

360 Figure 5 Cyclic voltammograms for liquid Zn electrode with an Al₂O₃ tube or a SiO₂

361 tube (left axis) and for Si plate electrode (right axis) in molten CaCl_2 at 1123

362 K. Scan rate: 100 mV s^{-1} .

363 Figure 6 Optical images of the SiO_2 plates after electrolysis at liquid Zn electrode or

364 immersion into liquid Zn for 30 min in molten CaCl_2 at 1123 K. (a)

365 potentiostatic electrolysis at 0.9 V, (b) immersion after electrolysis (a), (c)

366 potentiostatic electrolysis at 0.6 V, and (d) immersion after electrolysis (c).

367 Figure 7 (a) An optical image and (b) XRD pattern of the Si granules obtained after

368 acid leaching of Zn ingots. The electrolytic reduction of SiO_2 particles was

369 conducted at 0.6 V for 50 h at a liquid Zn cathode in molten CaCl_2 at 1123 K.

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371

372 **Table 1.** Impurity contents of Si granules obtained after acid leaching, and target levels
 373 for primary Si of SOG-Si. The electrolytic reduction of SiO₂ particles was conducted at
 374 0.6 V for 50 h at a liquid Zn cathode in molten CaCl₂ at 1123 K.

Impurity element, A	Acceptable level for SOG-Si ⁴¹ , $x_{A(\text{SOG-Si})} / \text{ppmw}$	Segregation coefficient ⁷ , k_A°	Target level for primary Si ^a , $x_{A(\text{primary})} / \text{ppmw}$	Impurity content of Si granules by electrochemical reduction at liquid Zn cathode, x_A / ppmw ^b	Impurity content of Si by direct electrochemical reduction ⁴² , x_A / ppmw ^c
B	0.1–0.3	0.8	0.13–0.38	1.5	2.6
P	0.03–0.04	0.35	0.086–0.4	<0.2	6.4
Al	<0.1	2×10^{-3}	<50	8	600
Ca	<0.2	1.6×10^{-3}	<125	85	5800
Fe	<0.1	8×10^{-6}	<12500	110	30
Ti	< 10^{-3}	9×10^{-6}	<100	25	19
Zn	— ^d	— ^d	— ^d	6055	2.1

375 a: $x_{A(\text{primary})} = x_{A(\text{SOG-Si})} / k_A^\circ$

376 b: Analyzed by ICP-AES

377 c: Analyzed by glow discharge-mass spectrometry (GD-MS)

378 d: No data

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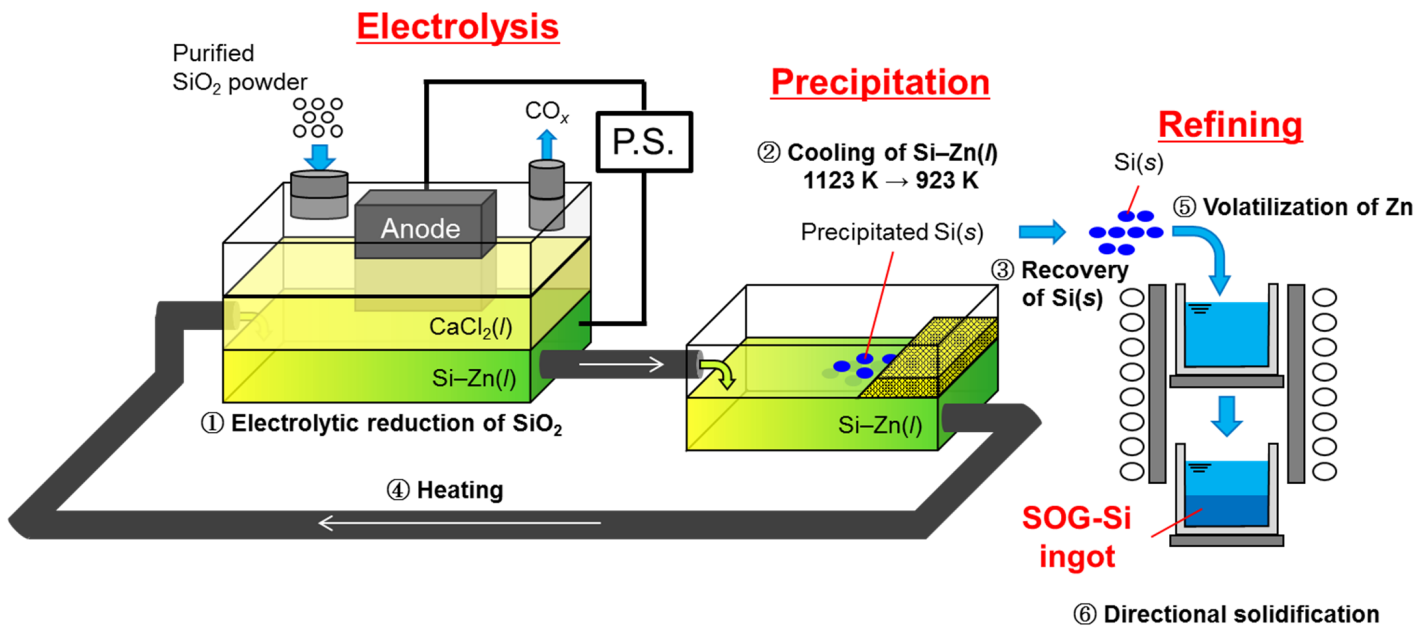


Figure 1. Schematic drawing of SOG-Si production process using electrochemical reduction of SiO_2 powder at a liquid Si-Zn alloy cathode in molten CaCl_2 .³⁸

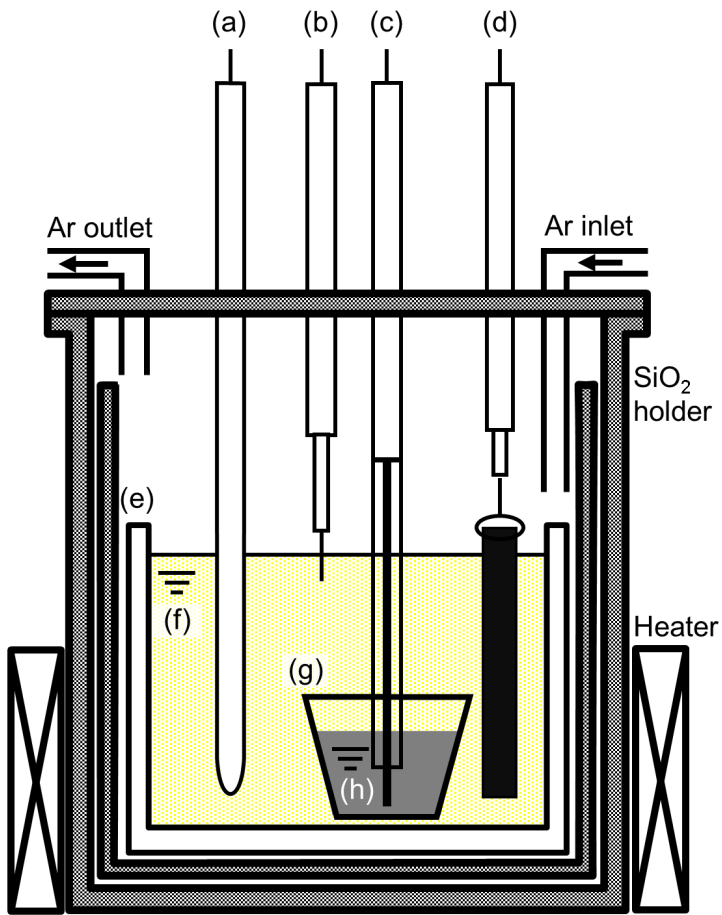


Figure 2. Schematic illustration of the electrolysis cell for observation of SiO₂ reduction behavior at liquid Zn cathode. (a) Ag⁺/Ag reference electrode, (b) Ca²⁺/Ca dynamic reference electrode on a Mo wire, (c) liquid Zn electrode with Al₂O₃/SiO₂ tube, (d) graphite counter electrode, (e) Al₂O₃ crucible, (f) molten CaCl₂, (g) small Al₂O₃ crucible, and (h) liquid Zn.

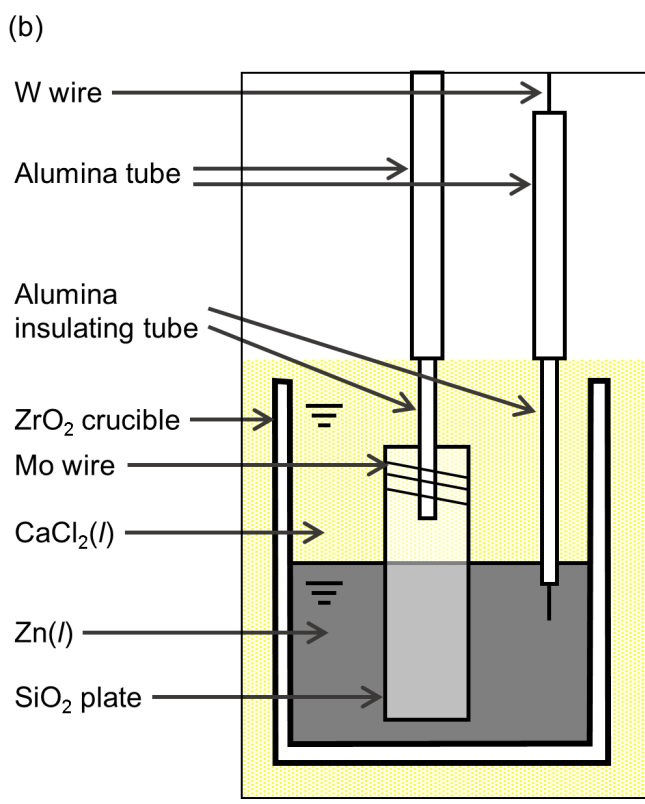
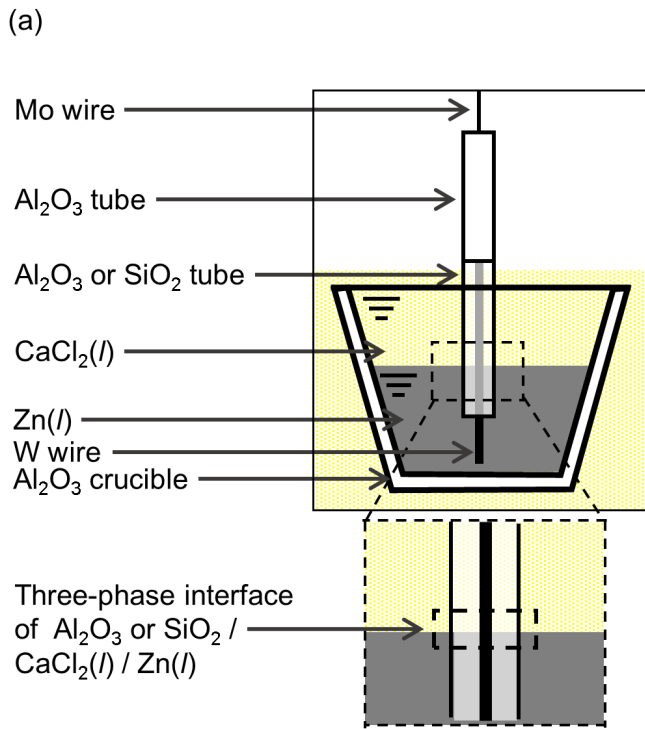


Figure 3. Schematic illustrations of the liquid Zn electrode for (a) cyclic voltammetry and (b) electrolytic reduction of SiO_2 plate

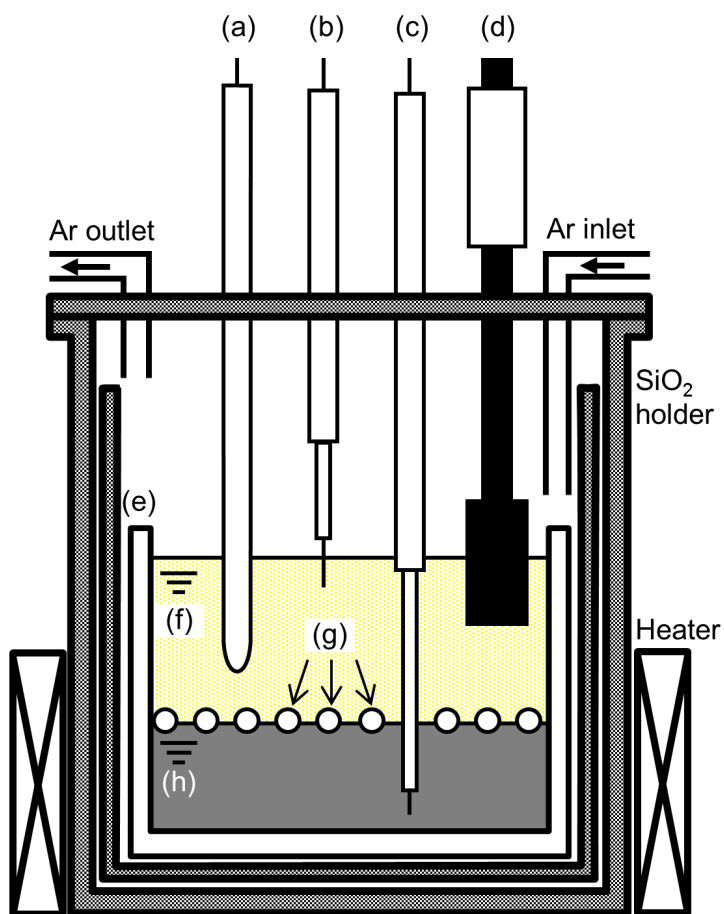


Figure 4. Schematic illustration of the electrolysis cell for the electrolytic reduction of SiO₂ particles. (a) Ag⁺/Ag reference electrode, (b) Ca²⁺/Ca dynamic reference electrode on a Mo wire, (c) W lead wire, (d) graphite counter electrode, (e) Al₂O₃ crucible, (f) molten CaCl₂, (g) SiO₂ particle, and (h) liquid Zn.

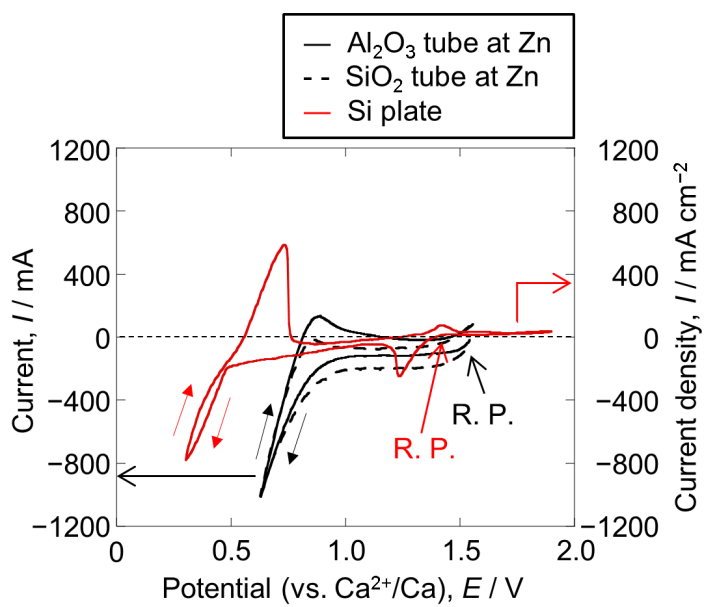


Figure 5. Cyclic voltammograms for liquid Zn electrode with an Al₂O₃ tube or a SiO₂ tube (left axis) and for Si plate electrode (right axis) in molten CaCl₂ at 1123 K. Scan rate: 100 mV s⁻¹.

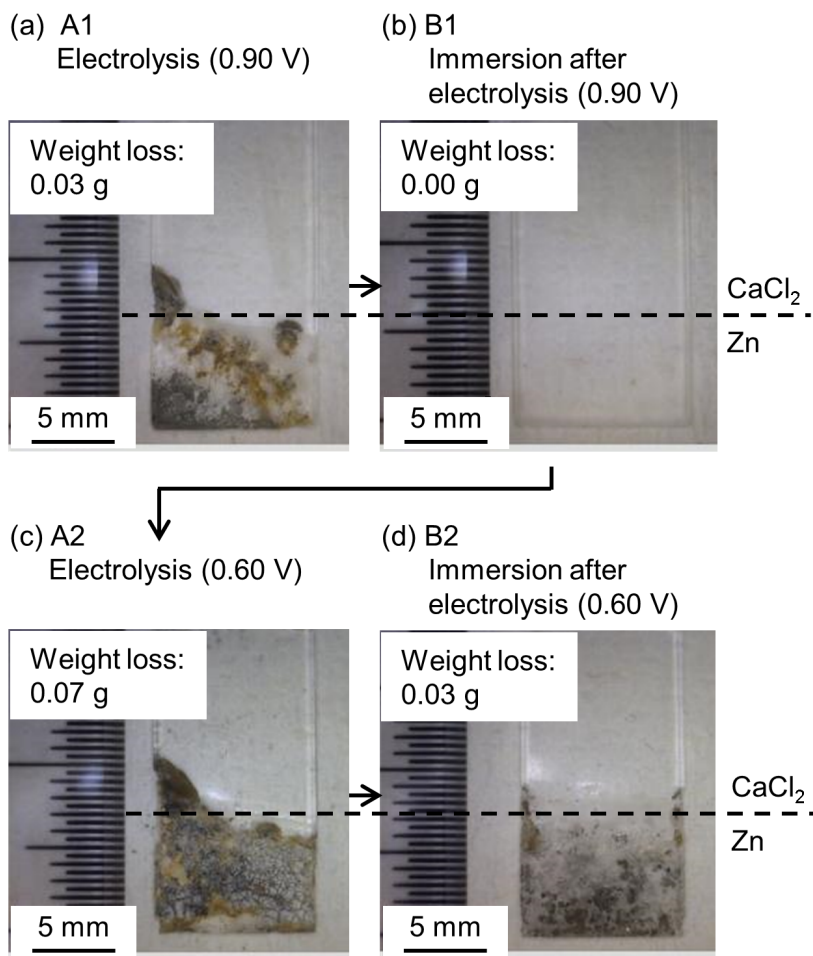
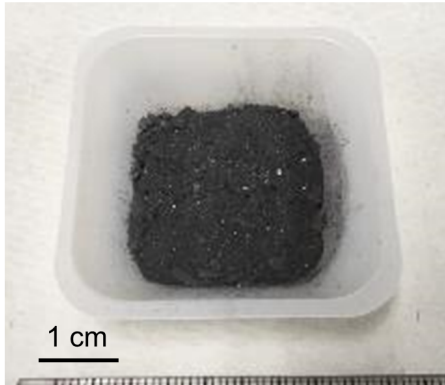


Figure 6. Optical images of the SiO₂ plates after electrolysis at liquid Zn electrode or immersion into liquid Zn for 30 min in molten CaCl₂ at 1123 K. (a) potentiostatic electrolysis at 0.9 V, (b) immersion after electrolysis (a), (c) potentiostatic electrolysis at 0.6 V, and (d) immersion after electrolysis (c).

(a)



(b)

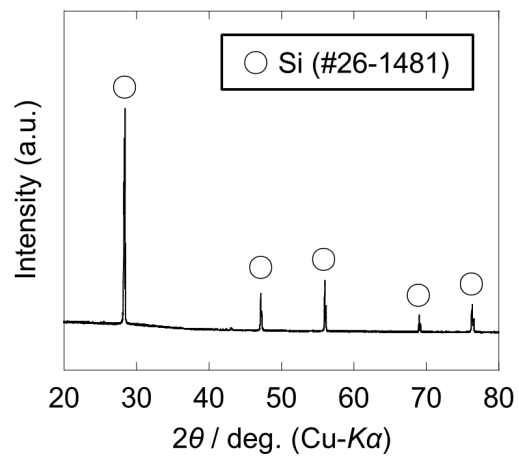


Figure 7. (a) An optical image and (b) XRD pattern of the Si granules obtained after acid leaching of Zn ingots. The electrolytic reduction of SiO_2 particles was conducted at 0.6 V for 50 h at a liquid Zn cathode in molten CaCl_2 at 1123 K.